

**Notice of References Cited**

Application/Control No.

10/685,169

Applicant(s)/Patent Under  
Reexamination  
KOLB ET AL.

Examiner

Elmira Mehrmanesh

Art Unit

2113

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,836,014 A	11-1998	Faiman, Jr., Robert Neil	717/156
*	B	US-2001/0025372 A1	09-2001	Vermeire et al.	717/7
*	C	US-2002/0059566 A1	05-2002	Delcambre et al.	717/146
*	D	US-2003/0005159 A1	01-2003	Kumhyr, David Bruce	709/246
*	E	US-6,623,529 B1	09-2003	Lakritz, David	715/205
*	F	US-2004/0024767 A1	02-2004	Chen, Dexing	707/100
*	G	US-2004/0268306 A1	12-2004	Cheng et al.	717/114
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U					
	V					
	W					
	X					

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.